University of Iowa Microfabrication Facility (UIMF)
User Fees FY18 Academic and External rates

Wet-Processing and Metrology Lab (IATL170)

Any tools excluding Oxidation furnace: $ 33/hr
Wet-bench: $ 20/hr
Oxidation furnace: $ 40/day

Thin Film, Etching and Nanoimprint Lab (IATL 174)

Cleanroom usage only: $ 27/hr.
Cleanroom access fee: $ 27/day (unlimited access for the day).
All tools: $ 55/hr.
Wet-bench: $20/hr.

Electron Beam (E-Beam) Nanolithography (IATL 172)

Cleanroom usage only: $ 27/hr.
Cleanroom access fee: $ 27/day (unlimited access for the day).
E-Beam Lithography: $ 70/hr.
Raith Voyager Imaging only: $ 35/hr

Staff Labor fee: $ 85/hr

Staff Training Fees

Tool in IATL 172 (Raith Voyager): $ 69/tool
Tools in IATL 174: $ 39/tool
Tools and Wet-processing in IATL 170: $ 29/tool
Penalty fees (reviewed on a case by case basis)

Failure to schedule tools on UIMF Tool scheduler prior to usage: $ 100
Failure to keep workspace/wet-bench tidy: $ 50
Failure to adhere to safety policies after 2nd warning: $ 100/hr, $ 100 minimum charge
(as per the UIMF safety manual)

Important Notes:
* Users who book tools in either IATL 172 or 174 will be automatically charged the cleanroom access fee.
* Users will be charged the cleanroom access fee once, for booking tools in 172 and 174 on the same day.
* All tool bookings are charged in 30 mins. increment and is the minimum charge, except for wet-benches, ovens and metrology tools which are 15 mins. minimum.
* Users are not charged for using hot-plates.
* Users will NOT be charged for simply swiping their card to access IATL 172 and 174 to collect items.
* External academic users and UI affiliated Industrial users will follow the same above charge model.
* Other External industrial users will be charged at 2.5 X the academic rates.

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